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JWD 6/11/07

RESPONSE UNDER 37 C.F.R.
§1.116 EXPEDITED PROCEDURE
EXAMINING GROUP 1723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mark S. Chace et al.

Examiner: Joseph W. Drodge

Serial No.: 10/695,374

Art Unit: 1723

Filed: October 28, 2003

Docket: FIS920030172US1 (16645)

For: PROCESS FOR REMOVING
IMPURITIES FROM LOW DIELECTRIC
CONSTANT FILMS DISPOSED ON
SEMICONDUCTOR DEVICES

Dated: May 31, 2007

Confirmation No.: 5323

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Official Action dated April 24, 2007, please amend the above-identified application as follows:

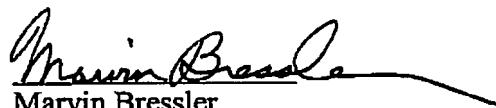
Amendment to the claims begin at Page 2 of this paper.

Remarks/Arguments begin at Page 8 of this paper.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on May 31, 2007.

Dated: May 31, 2007


Marvin Bressler